

IFW



**PATENT APPLICATION  
Q76291**

**IN THE UNITED STATES PATENT & TRADEMARK OFFICE**

In re application of

Hirofumi FUJIOKA, *et al.*

Appln. No.: 10/609,476

Group Art Unit: 2813

Confirmation No.: 2217

Examiner: Stephen W. Smoot

Filed: July 1, 2003

For: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

**AMENDMENT UNDER 37 C.F.R. §1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 17, 2004, please amend the above-identified application as follows on the accompanying pages.

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